

Docket No.: WRA-32830

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Date: April 22, 2003

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
Before the Board of Patent Appeals and Interferences

Inventor : Karl Draganitsch et al.  
Appl. No. : 09/817,573  
Filed : March 26, 2001  
Title : Method of Producing a Wafer Product, Assembly for Implementing the Method, and Wafer Product Produced According to the Method  
Examiner : Thuy Tran Lien Art Unit: 1761

NOTICE OF APPEAL FROM THE PRIMARY EXAMINER TO THE  
BOARD OF PATENT APPEALS AND INTERFERENCES

Hon. Commissioner of Patents and Trademarks,  
Washington, D. C. 20231

Sir:

Applicants hereby appeal to the Board of Patent Appeals and Interferences from the decision dated January 23, 2003 of the Primary Examiner finally rejecting claims 1-6.

The \$320.00 appeal fee is enclosed.

The Patent and Trademark Office is hereby given authority to charge Deposit Account No. 12-1099 of Lerner and Greenberg, P.A. for any fees due or deficiencies of payments made for any purpose during the pendency of the above-identified application.

Respectfully submitted,

For Applicants

Date: April 22, 2003

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